

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No.09/905,320
Filing Date July 13, 2001
Inventor Basceri et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Eric B. Fuller
Attorney Docket No.MI22-1657
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium
Titanate Comprising Dielectric Layers, Including Such Layers Having a
Varied Concentration of Barium and Strontium Within the Layer

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR
§1.56. Copies of the cited art are included. No admission is made regarding
whether all the submitted references are prior art.

Respectfully submitted,

Dated: 8/4/03

By: [Signature]

Mark S. Matkin
Reg. No. 32,268

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1657	SERIAL NO. 09/905.320
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Basceri et al.	
				FILING DATE July 13, 2001	GROUP 1762

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U.S. PATENT DOCUMENTS							
Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,338,970 B1	01/15/02	Suh			
	AB						
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FOREIGN PATENT DOCUMENTS							
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